

Temperature Dependent Dielectric Functions of Topological Insulators Ellie Holmgren '18 and Frank Peiris Kenyon College Summer Science 2017

Abstract

Topological insulators (TI) are semiconductors with a special property which allows them to conduct charge on their thin surfaces (~5-10 nm) while having an insulating phase in their bulk. In this work, we studied a series of topological insulators (i.e., Bi₂Te₃, Bi₂Se₃ and their alloys) that were grown on top of GaAs substrates using molecular beam epitaxy. The samples were scanned using spectroscopic ellipsometry between 200 nm and 1600 nm. In order to determine the temperature dependent properties, we recorded scans from 22 K to 300 K using a liquid-heliumcooled cryostat. The experimental spectra were modelled to obtain the dielectric functions of the topological insulators. Specifically, we used a free-electron oscillator, called a Drude oscillator, to model the conduction of the surface layer of the topological insulator. Additionally, another oscillator was included to model the band gap properties of the bulk layer. By tracking the parameters of the two oscillators, we were able to deduce how the electrical conductivity, and the band gap properties evolve as a function of both alloy concentration and temperature.



Oscillators

Results

Drude and CPM0 contributions to modelling ε_2 • ε_2 Drude ε₂ CPM0 ε, Both 0.0 -0.2 0.3 0.4 0.5 0.6 0.7 0.8 Energy (eV) Figure 6: Oscillator Contributions to Dielectric component, ϵ_2

Introduction to Material



Figure 2: Overview of spectroscopic ellipsometry [2]

Experimental Details

For each sample, we followed a data collection procedure:

- Place sample in cryostat under vacuum
- Heat to remove protective Selenium layer from the sample
- Use Liquid Helium to take Temperature dependent Spectroscopic Ellipsometry scans at 20K, 66K, 100K, 150K, 200K, 300K
- Model these scans in order to determine the Temperature **Dependent Dielectric Functions**

Selenium Cap Removal

Each sample comes with a layer of Selenium to keep it from oxidizing and corrupting the surface. This cap has a lower boiling point than the sample and its substrate. Hence, to remove the cap, we heat it in vacuum for 10 minutes, monitoring the intensity of the light reflected by the sample. The sudden increase in intensity suggests, the evaporation of the cap-layer.



Figure 3: Cryostat used to perform lowtemperature measurements

Se Cap

Topological Insulator



Isotropic vs anisotropic





indicate protected surface spin states which also make this material unique.

7 Topological Insulator Samples • Studied:

- Bi₂Te₃
- Bi₂Se₃

ellipsometry.

Momentum Figure 1: Band structure of Topological Insulator [1] 5 alloys: Bi₂(SeTe)₃

Fermi level

Approximate percentage Selenium for each alloy: 30%, 45%, 50%, 63%, 93%

Conduction band

Valence band

Surface states

Theory

Spectroscopic Ellipsometry is a technique in which linearly polarized light of a single wavelength is reflected off of a sample and the reflected polarization and intensity is recorded. This information is interpreted into two quantities, ψ and Δ . The ψ corresponds more to the relative intensity between the two polarized light waves, while Δ corresponds to the relative phase difference. The equation that governs this relationship is given as follows:

 $= \tan(\psi)e^{i\Delta}$

Right, Figure 5: Intensity vs Time for Selenium Layer Removal Process

Modelling Ellipsometry Data



GaAs Substrate Heat Figure 4: Cross-section of sample, not to scale





dielectric function for Bi₂Te₃

, vs Energy for all Temperatures

ample Bi₂(SeTe)₃ (45% Se)

Figure 10: ϵ_2 vs Energy for a

sample at six different

Temperatures

emperatur

100K 150K

22K

Each model uses two

Drude models

absorption of free

conducting surface.

CPM0 models the

properties

electrons related to the

materials bulk band gap

For each set of ellipsometry

When a mathematical model

data, we applied all three

fits well, we can use the

models independently.

oscillators:

modelled dielectric function for Bi₂Te₃

Generally, Uniaxial Anisotropy improved fits by 10-30%.



Figure 11: En vs Temperature for five samples. En is an oscillator parameter related to the band gap energy

References and Acknowledgements

[1] By A13ean (Own work) [CC BY-SA 3.0 (http://creativecommons.org/licenses/by-sa/3.0)] via Wikimedia Commons [2] Buntgarn, at the English Wikipedia project [CC-BY-SA-3.0] (http://creativecommons.org/licenses/by-sa/3.0/)], via Wikimedia Commons

In this case, R_p and R_s are the total reflection coefficients with respect to the p and s polarizations. Both R_p and R_s are complex numbers which are related to the dielectric function and thickness of the sample that is monitored via

Each sample was modelled in three ways; • One layer isotropic oscillator model

One layer anisotropic oscillator model

• Two oscillator layers, lower layer anisotropic model

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